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DATE MAILED: 10/06/2005

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/767,625	01/28/2004	Srinivasamohan Narayanan	SL1207 5653		
75	90 10/06/2005		EXAMINER		
BP America Inc.			MENZ, DOUGLAS M		
Docket Clerk					
BP Legal, M.C 5 East			ART UNIT	PAPER NUMBER	
4101 Winfield Road			2891		
Warrenville, IL	. 60555				

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No. Applicant(s)						
Office Action Summary		10/767,625	NARAYANAN ET AL.		(hy			
		Examiner	Art Unit					
		Douglas M. Menz	2891					
Period fo	The MAILING DATE of this communication a or Reply	ppears on the cover sheet with the	correspondence a	ddress				
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).								
Status								
1)	Responsive to communication(s) filed on 20	June 2005						
2a)□		nis action is non-final.						
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
٥,۵	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 455 C.G. 213.							
Dispositi	on of Claims							
4)⊠	☑ Claim(s) <u>1-27</u> is/are pending in the application.							
	4a) Of the above claim(s) 1-16 and 22-27 is/are withdrawn from consideration.							
5)[	Claim(s) is/are allowed.							
6)⊠	Claim(s) <u>17-21</u> is/are rejected.							
7)	Claim(s) is/are objected to.							
8)[	Claim(s) are subject to restriction and	or election requirement.						
Applicati	on Papers							
9)	The specification is objected to by the Examir	ner.						
	10)⊠ The drawing(s) filed on <u>28 January 2004</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
,—	Applicant may not request that any objection to th		•					
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
	inder 35 U.S.C. § 119							
	Acknowledgment is made of a claim for foreig	en neiseite under 25 H C C C 440/s	. (4) (6)					
	☐ All b)☐ Some * c)☐ None of:	gripholity under 35 0.5.C. § 119(a	)-(u) or (i).					
Δ) <sub>L</sub>	1. ☐ Certified copies of the priority documer	ata baya baan ragaiyad						
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	3. Copies of the certified copies of the pri		ed in this National	Stage				
* 0	application from the International Bure	• • • • • • • • • • • • • • • • • • • •	i					
	ee the attached detailed Office action for a lis	st of the certified copies not receive	<b>∌</b> a.					
•	•							
Attachmen								
1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)								
	e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08	Paper No(s)/Mail Do  5) Notice of Informal F		O-152)				
	No(s)/Mail Date <u>5/9/05, 8/10/04</u> .	6) ⊠ Other: <u>Search Histo</u>		,				
Botost and To								

#### **DETAILED ACTION**

## Election/Restrictions

Applicant's election with traverse of Species IIa of Group II, claims 17-21, in the reply filed on 6/20/05 is acknowledged. The traversal is on the ground(s) that the Examiner has not shown enough evidence to support the restriction. This is not found persuasive because it has been shown in paper dated 5/19/05 that a restriction requirement was proper. To further expand on the restriction requirements as to the product and process of making, the product as claimed does not require the removal of a second dopant from the back surface. Therefore, a process which incorporates a masking of the back surface prior to the forming of the first layer would constitute a materially different process of manufacturing the product as claimed. Regarding the Species restriction, the dividing of related inventions is proper on the grounds that different fields of search are necessary given the fact that different limitations are claimed.

The requirement is still deemed proper and is therefore made FINAL.

## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

<sup>(</sup>b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 17 and 21 are rejected under 35 U.S.C. 102(b) as being anticipated by Fraas et al. (US 5091018).

Regarding claim 17, Fraas et al. (US 5091018) discloses a process for making a photovoltaic device using a substrate comprising silicon doped with a first dopant (Col. 6, lines: 18-30), the process comprising the steps of:

- (a) forming a first layer (64, Fig. 8A) of the substrate (61, Fig. 8A), the first layer comprising a second dopant (p-type) of a conductivity type opposite the first dopant (n-type) (Col. 6, lines: 58-65);
- (b) forming a surface coating (62, Fig. 8A) disposed over the substrate such that a back surface of the substrate is free or substantially free of the surface coating (Col. 6, lines: 36-40); and
- (c) removing the second dopant from the back surface (65, Fig. 8A-B) such that the back surface is free or substantially free of the second dopant (Col. 7, lines: 1-18).

Regarding claim 21, Fraas further discloses wherein the surface coating (62) comprises silicon nitride (Col. 6, lines: 36-39).

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the

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invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 18-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Fraas et al. (US 5091018) in view of Rittner (US 4135950).

Regarding claim 18, Fraas discloses the process of claim 17 as mentioned above. However, Fraas does not disclose further comprising the step of texturing the substrate.

Rittner discloses a silicon solar cell structure wherein the substrate is textured (Fig. 2 and Col. 2). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to texture Fraas's substrate as taught by Rittner because Rittner explicitly discloses that such features are for optimizing the power output of the solar cell throughout its design lifetime (Col. 2, lines: 55-65).

Regarding claim 19, Rittner further discloses the process of removing the texture from the back surface such that the back surface is substantially smooth (Fig. 2 and Col. 1, lines: 54-55 and Col. 2, lines: 40-45). It would have been obvious to one of ordinary skill in the art at the time the invention was made to remove the texture from the back surface such that the back surface is substantially smooth because Rittner explicitly discloses such a step in the process of forming an electron reflecting region (Col. 2, lines: 40-46).

Regarding claim 20, Rittner further discloses the step of forming a back surface field (p+ region, Fig. 2 and Col. 2, lines: 40-47). It would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate a back surface field into Fraas's device for the purpose of increasing the efficiency of the device. To further support the Examiner's position that Rittner's p+ region constitutes a back surface field used to increase the efficiency of the device see Mowles (US 6541695) (Fig. 2A and Col. 10, lines: 5-20).

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Douglas M. Menz whose telephone number is 571-272-1877. The examiner can normally be reached on M-F 8-5.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Bill Baumeister can be reached on 571-272-1722. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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